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**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 2818
PATENT
Customer No. 22,852
Attorney Docket No. 04329.3238**



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Gaku MINAMIHABA et al.) Group Art Unit: 2818
Application No.: 10/771,060)
Filed: February 4, 2004) Examiner: Goodwin, David J.
For: POLISHING PAD AND METHOD) Confirmation No.: 2231
OF MANUFACTURING)
SEMICONDUCTOR DEVICES) Mail Stop AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action mailed March 10, 2008, the period for response to which extending through June 10, 2008, Applicants propose amending this application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment section of this paper.